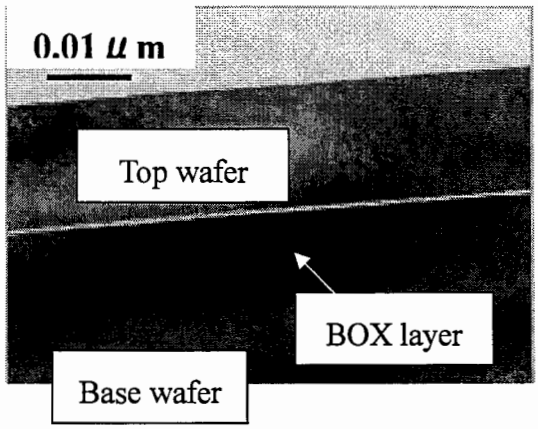
Fig. 1

Cross-section of the wafer before heat treatment in reducing atmosphere



Cross-section of the wafer after heat treatment in reducing atmosphere

